	Туре	Hits	Search Text	DBs	Time Stamp	Co mm ent	Co Err mm Def Err Ref ent initi	Err	Ref #
13	BRS	-	CD adj measur\$5 and beam near5 align\$5	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	2005/03/25 09:57				S14
14	BRS	167	wafer adj inspection and beam near5 align\$5	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	2005/03/25 09:58				S15
15	BRS	49	S15 and critical adj dimension	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	2005/03/25 10:00			U,	S16
. 16	BRS	40	S16 and electron adj beam	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	2005/03/25 10:01				S17
17	BRS	0	S17 and SEM adj align\$5	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	2005/03/25 10:01				S18
8	BRS	-	S15 and SEM adj align\$5	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	2005/03/25 10:01				S19

Туре	Hits	Search Text	DBs	Time Stamp	Co Or Err Refemble Bent initi	Err or Err F liniti on	Err F
<u>~</u>		250/310 and CD adj measur\$5 and beam near5 align\$5	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	2005/03/25 10:02			S13
		250/310 and CD adj measur\$5 and alignment adj mark	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	2005/03/25 10:02			S20
	20	CD adj measur\$5 and alignment adj mark	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	2005/03/25 10:07			S21
		S21 and electron adj beam	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	2005/03/25 10:07			\$22
<u> </u>	50	S23 and electron adj beam	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	2005/03/25 10:07			S24
3,	28	wafer adj inspection and alignment adj mark and SEM	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	2005/03/25 10:1,			S23

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Time Stamp	2005/03/25 10:32	2005/03/25 10:33	2005/03/25 10:33	2005/03/25 10:48
DBs	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
Search Text	wafer adj inspection and conventional near5 alignment adj mark and SEM	wafer adj inspection and known near5 alignment adj mark and SEM	wafer adj inspection and alignment adj mark near5 beam	archie-charles-n.in.
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Туре	BRS	BRS	BRS	BRS
	25	26	27	78